

**LIST OF PRIOR ART CITED BY  
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2875

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PATENT 2877

## U.S. PATENT DOCUMENTS

## FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No
RLW	63131436 A	06/03/88	JAPAN			X	
RLW	02148645 A	06/07/90	JAPAN			X	
RLW	05250992 A	09/28/93	JAPAN			X	
RLW	04272634 A	09/29/92	JAPAN			X	
RLW	06044907	02/18/94	JAPAN			X	
RLW	4280289	10/06/92	JAPAN			X	

**OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)**

EXAMINER	<u>Amber</u>
DATE CONSIDERED	APRIL 09, 2001

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